

RECEIVED

SEP 15 2003

214890US-2S

IN THE UNITED STATES PATENT & TRADEMARK OFFICE
POST OFFICE CENTER 2800

IN RE APPLICATION OF: :
HIROSHI WATANABE ET AL. : EXAMINER: PHAM, HOAI V.
SERIAL NO. : 09/973,019 :
FILED: OCTOBER 10, 2001 : GROUP ART UNIT: 2814
FOR: SEMICONDUCTOR DEVICE AND:
METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22313

SIR:

In response to the Official Action dated June 18, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper and include an attached replacement sheet and new drawing sheet.

Amendments to the Claims begin on page 5 of this paper.

Remarks/Arguments begin on page 18 of this paper.

09/30/2003 AMISE1 00000004 09973019
01 FC:1201 84.00 0P